

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Hiroto OHTAKE, et al.

Appln. No.: 10/080,848

Art Unit: 1765

Filed: February 22, 2002

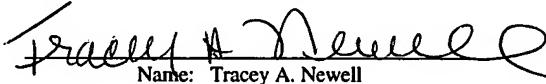
Examiner: DEO, Duy Vu Nguyen

For: METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE CAPABLE OF ETCHING A MULTI-LAYER OF ORGANIC FILMS AT A HIGH SELECTIVITY

Docket No.: KRM-00101

Certificate of Mailing

I hereby certify that the foregoing documents are being deposited with the United States Postal Service as first class mail, in an envelope addressed to the Commissioner for Patents; P.O. Box 1450, Alexandria, VA 22313-1450 on this date of January 25, 2005.


 Name: Tracey A. Newell

PETITION FOR EXTENSION OF TIME

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450
 Sir:

This is a request to extend the period for filing a response in the above-identified application for one month from January 7, 2005 to February 7, 2005. Enclosed is a check for \$120.00 to cover the extension fee.

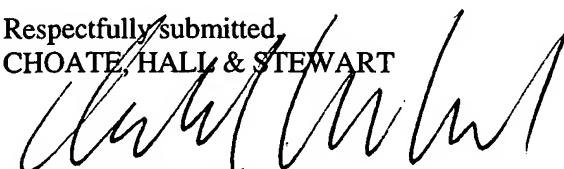
Although we believe that we have submitted the correct amount to cover the requested extension of time, the Commissioner is authorized to credit any overpayment or charge any deficiencies to our **Deposit Account No. 031721**. Two originally-executed copies of this form are being submitted.

Should there be any questions after reviewing this paper, the Examiner is invited to contact the undersigned at (617) 248-4038.

01/31/2005 HAL111 00000056 10080848
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January 25, 2005
 Date

Respectfully submitted,
 CHOATE, HALL & STEWART


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